



MAIL STOP AMENDMENT

*JWJ*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: F.M. Schellenberg et al. Attorney Docket No.: MEGC122529

Application No.: 10/811,418 Art Unit: 2825 / Confirmation No.: 2647

Filed: March 26, 2004 Examiner: Binh C. Tat

Title: CREATING PHOTOLITHOGRAPHIC MASKS

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Seattle, Washington 98101

February 15, 2006

TO THE COMMISSIONER FOR PATENTS:

Applicants are aware of the information listed in the attached form that may be material to the prosecution of the above-identified patent application.

1. X Pursuant to 37 C.F.R. § 1.97(c), this Supplemental Information Disclosure Statement is being filed after the period set forth in 37 C.F.R. § 1.97(b) but before the mailing date of a final action under 37 C.F.R. § 1.113, a Notice of Allowance under 37 C.F.R. § 1.311, or an action that otherwise closes prosecution, and is accompanied by:
  - a. X the submission fee set forth in 37 C.F.R. § 1.17(p). Check No. 168679 in the amount of \$180 is enclosed.

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CHRISTENSEN O'CONNOR JOHNSON KINDNESS<sup>PLC</sup>  
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2. X The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account No. 03-1740. A copy of this document is enclosed.

Respectfully submitted,

CHRISTENSEN O'CONNOR  
JOHNSON KINDNESS<sup>PLLC</sup>



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I hereby certify that this correspondence is being deposited with the U.S. Postal Service in a sealed envelope as first class mail with postage thereon fully prepaid and addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the below date.

Date: February 15, 2006  
RCT:jh



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**SUPPLEMENTAL INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL  
TO THE PROSECUTION OF THE SUBJECT APPLICATION**

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**U.S. PATENT DOCUMENTS**

*Examiner	Cite Initials	Cite No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
	U16		6,416,907	B1	07/09/2002	Winder et al.
	U17		6,620,561	B2	09/16/2003	Winder et al.

**FOREIGN PATENT DOCUMENTS**

*Examiner	Cite Initial	Cite No.	Document No.	Kind Code	Publication Date (mm/dd/yyyy)	Country	English Provided	Abstract Provided	Translation Provided

None

**OTHER INFORMATION**  
(Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner	Cite Initial	Cite No.

None

**Examiner** **Date Considered**

\*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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